



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

April 2, 2026	
IGI Report Number	LG788668326
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	MODIFIED DECAGONAL STEP CUT
Measurements	15.56 X 7.29 X 4.87 MM

GRADING RESULTS

Carat Weight	3.81 CARATS
Color Grade	F
Clarity Grade	VVS 2

ADDITIONAL GRADING INFORMATION

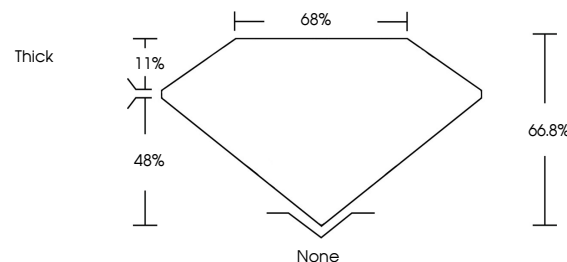
Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE

Inscription(s)  LG788668326

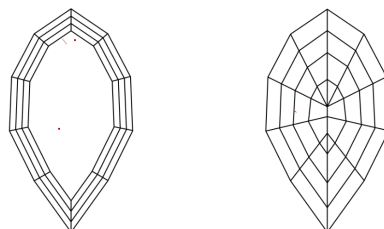
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG788668326
Report verification at lgi.org

PROPORTIONS

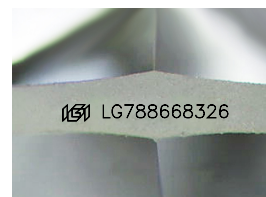


CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

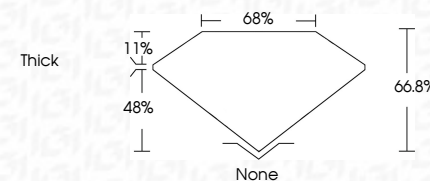
CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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www.igi.org

	Wt %
Color Grade	F
Clarity Grade	VVS 2
Depth	66.8%
Table	68%
Girdle	Thick
Culet	None
Pavilionsymmetry	EXCELLENT
Fluorescence	EXCELLENT
Inscriptions(s)	NONE
	#JL789649326

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 (CVD) growth process.
 Type IIa